# The United States America

# The Director of the United States Patent and Trademark Office

Has received an application for a patent for a new and useful invention. The title and description of the invention are enclosed. The requirements of law have been complied with, and it has been determined that a patent on the invention shall be granted under the law.

Therefore, this

# **United States Patent**

Grants to the person(s) having title to this patent the right to exclude others from making, using, offering for sale, or selling the invention throughout the United States of America or importing the invention into the United States of America for the term set forth below, subject to the payment of maintenance fees as provided by law.

If this application was filed prior to June 8, 1995, the term of this patent is the longer of seventeen years from the date of grant of this patent or twenty years from the earliest effective U.S. filing date of the application, subject to any statutory extension.

If this application was filed on or after June 8, 1995, the term of this patent is twenty years from the U.S. filing date, subject to any statutory extension. If the application contains a specific reference to an earlier filed application or applications under 35 U.S.C. 120, 121 or 365(c), the term of the patent is twenty years from the date on which the earliest application was filed, subject to any statutory extensions.

Jon W. Dudas

Director of the United States Patent and Trademark Office



US006818541B2

# (12) United States Patent

Yang et al.

(10) Patent No.:

US 6,818,541 B2

(45) Date of Patent:

Nov. 16, 2004

### (54) METAL BONDING METHOD FOR SEMICONDUCTOR CIRCUIT COMPONENTS EMPLOYING PRESCRIBED FEEDS OF METAL BALLS

(75) Inventors: Cheng-Chieh Yang, Taipei (TW);
Wen-Long Chen, Taipei (TW);
Yao-Huang Tsai, Taipei (TW);
Chih-Liang Hu, Taipei (TW); Pan-Nan

Chen, Keelung (TW)

73) Assignee: Comchip Technology Co., Ltd., Taipei Hsien (TW)

(\*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35

U.S.C. 154(b) by 0 days.

(21) Appl. No.: 10/249,572

(22) Filed: Apr. 21, 2003

(65) Prior Publication Data

US 2004/0185650 A1 Sep. 23, 2004

(30) Foreign Application Priority Data

(51) Int. Cl.<sup>7</sup> ...... H01L 21/44

(52) **U.S. Cl.** ...... 438/612; 438/613; 438/615

### (56) References Cited

### U.S. PATENT DOCUMENTS

5,880,017	Α	*	3/1999	Schwiebert et al 438/613
5,985,694	A	*	11/1999	Cho 438/108
6,234,373	B1	*	5/2001	Wark 228/19
6,475,897	B1	*	11/2002	Hosaka 438/617

### OTHER PUBLICATIONS

Brazing ans Soldering Alloys, N. MacQuesten Parkway, Mount Vernon, N. Y.\*

Silvabrite 100 Product sheet from Engelhard, 1987.\*

\* cited by examiner

Primary Examiner—Ha Tran Nguyen

(74) Attorney, Agent, or Firm-Jiang Chyun IP Office

(57) ABSTRACT

A method for fabricating metal bonding for a semiconductor circuit component employing prescribed feed of metal ball is disclosed. The method comprises the steps of, first, placing a metal ball at the metallization site on the surface of the circuit die of the component; then, melting the metal ball on the site; and subsequently solidifying the molten metal and forming a metal bump at the site. A circuit die having formed with one or more metal bumps can then be made into a circuit component featuring stable and reliable electrical leads and suitable to be utilized as large power rating yet with reduced component size in electronic equipment.

### 9 Claims, 7 Drawing Sheets



